



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Bradley Dale Mitchell  
SERIAL NO.: 09/943,569  
FILING DATE: August 30, 2001  
TITLE: System and Method for Removing Deposited Material from Within a Semiconductor  
EXAMINER: Alexander Markoff  
TELEPHONE: (571) 272-1304  
FAX: (703) 872-9306  
ART UNIT: 1746

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Name:

Beatrice Orozco  
Beatrice Orozco

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RESPONSE TO RESTRICTION REQUIREMENT

This paper is responsive to the restriction requirement dated July 28, 2004.

Listing of Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper